Model : TL303S


This photograph is a production example.

## Product specifications

## Input voltage

90V~240VAC single phase 1.5A(50,60HZ)
Accelerator supply (Referenced to GND)
Output voltage:
-1K~-30kV
Absolute voltage accuracy: Less than $0.1 \%$
Set ability: $\quad 12$ bit (10V LSB)
Output current: $\quad 200 \mu$ A max
Ripple noise:
Stability: temperature coefficient:

250 mV -p or less
50ppm/1hr after 1 hr warm up
$25 \mathrm{ppm} /{ }^{\circ} \mathrm{C}$
Filament supply (Referenced to Accelerator)
Output voltage: 0~5V

Set ability: $\quad 12$ bit (1mA LSB)
Output current: 0~3.3A
Ripple noise: Less than 10 mA @3A
Absolute current accuracy: $\pm 0.01 \mathrm{~A}$
Stability: temperature coefficient:

200ppm/1hour @ 3.0A

Bias Supply
Output voltage: 3.0kV max
Method of bias:
active bias or self bias

Details decides it by the consultation with the customer.

Custom multiple output power supply for " Scanning electron microscope with LaB6-gun" .

Application

- Scanning electron microscope
- Electron probe micro analyzer
- Auger micro probe analyzer

This is a product only for the custom order that supplies OEM according to customer's system.

The other specifications
All the outputs provide with the over voltage protection and the over current protection.

External control: Optical isolated RS232C
Interlock: vacuum, thermo, HV-connection
HV connector: Customer specification
Output monitor: Accelerating voltage
Storage temp range: $\quad-5^{\circ} \mathrm{C} \sim+40^{\circ} \mathrm{C}$
Operating temperature
Limit: $\quad+10^{\circ} \mathrm{C} \sim+40^{\circ} \mathrm{C}$ Humidity: $80 \%$ or less
Insulation method: Air insulation (one molding) Externals size: --- (W) $\times$--- (D) $\times$--- (H) Weight: --- kg

The model "TL303S" is an integrated multiple output high voltage power supply specifically developed for LaB6gun type scanning electron microscope.

Please ask details. e-mail info@futex.jp

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